

Electronic Patent Application Fee Transmittal

Application Number:	10648231			
Filing Date:	27-Aug-2003			
Title of Invention:	SYSTEM AND METHOD FOR EVALUATING A SEMICONDUCTOR DEVICE PATTERN, METHOD FOR CONTROLLING PROCESS OF FORMING A SEMICONDUCTOR DEVICE PATTERN AND METHOD FOR MONITORING A SEMICONDUCTOR DEVICE MANUFACTURING PROCESS			
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Filer:	Melvin Kraus/Ricardo Perez			
Attorney Docket Number:	520.43079X00			
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Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1400	1400
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Miscellaneous:				
Printed copy of patent - no color	8001	4	3	12
Total in USD (\$)				1712